

Advancements in Fine Line Metallization: Latest Achievements at Fraunhofer ISE

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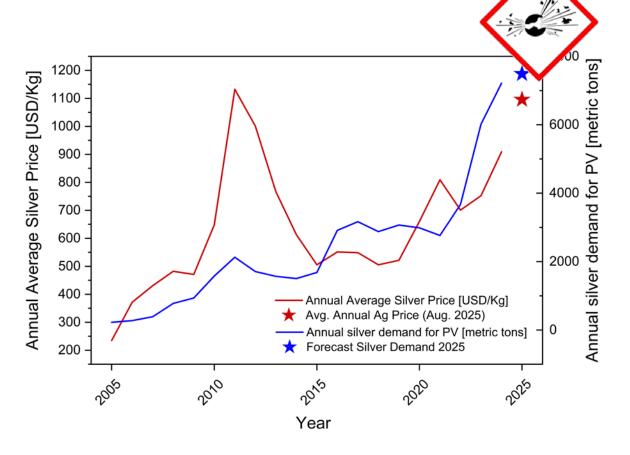
13th Metallization and Interconnection Workshop October 21st 2025, Berlin

Motivation

There is no alternative to drastic silver reduction

Silver demand for the PV industry 2025:

- Silver price reaches new record highs (> 52 \$/Oz)
- PV silver demand of PV expected to reach > 7,5 kt [1]
- "Explosive mix" for PV industry



Evolution of silver price [\$/Kg] and yearly total silver demand [Tons] from 2005 to 2025 (forecast). Source: The Silver Institute [2]

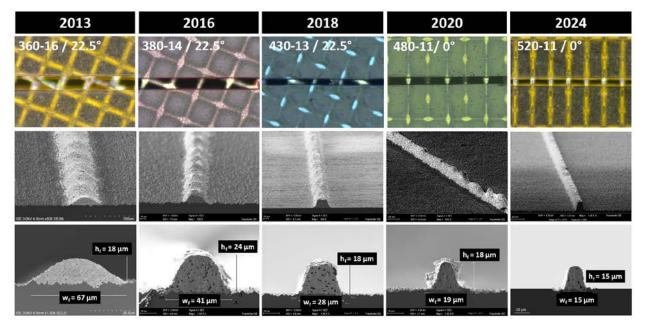


Motivation

There is no alternative to drastic silver reduction

Impact on PV industry:

- Strong pressure to drastically reduce/replace Ag
- Possible solutions:
 - ➤ Silver reduction by fine line printing,
 Rapid development of new screens & pastes [1]
 → Approaching 10 µm in industrial mass production [2,3]



Evolution of fine line screen printing at Fraunhofer ISE: Microscopic images of different screen types and SEM images of selected front side contacts (Al BSF and PERC) from 2013 to 2024. Source: Fraunhofer ISE



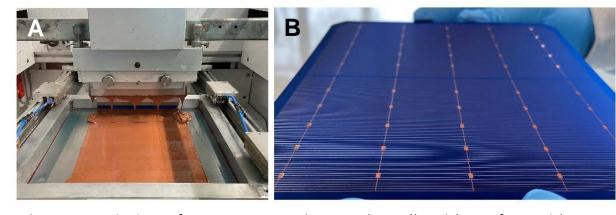
[2] N. Chen, this workshop

Motivation

There is no alternative to drastic silver reduction

Impact on PV industry:

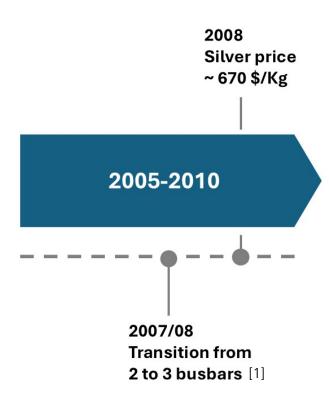
- Strong pressure to drastically reduce/replace Ag
- Possible solutions:
 - Silver reduction by fine line printing,
 Rapid development of new screens & pastes [1]
 → Approaching 10 µm in industrial mass production [2,3]
 - Replacement of silver (i.e. AgCu ^[1,2], Copper ^[2] or Nickel ^[3] paste),

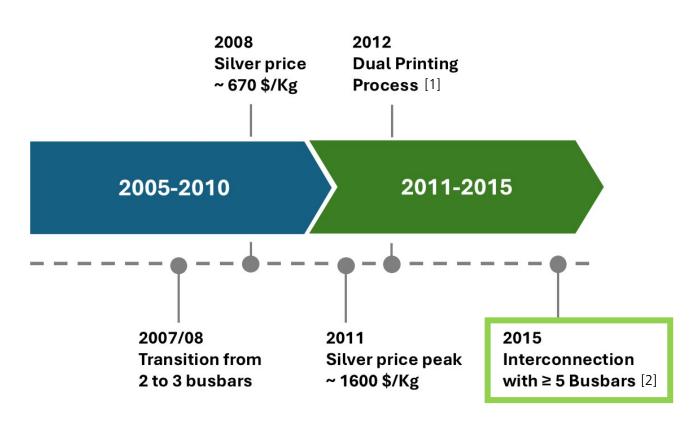


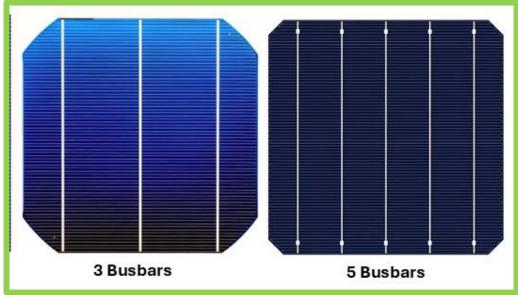
A) Screen printing of copper paste B) SHJ solar cells with Cu front side metallization (Source: Fraunhofer ISE)







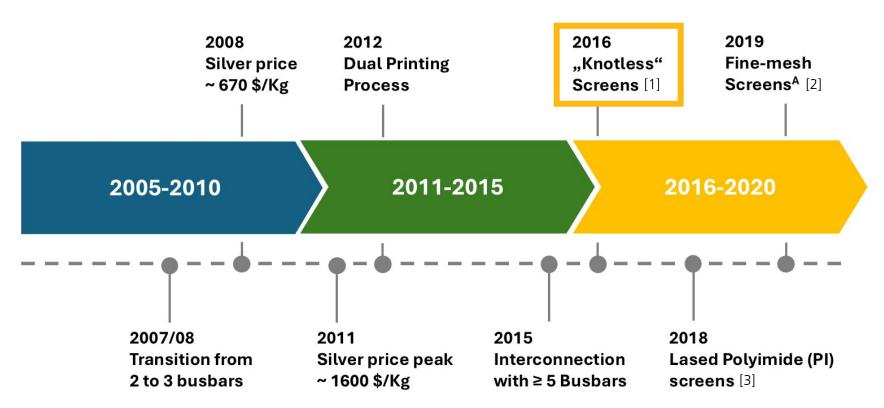


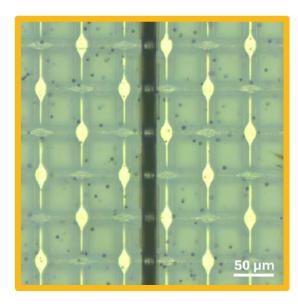


Silicon solar cells with 3 and 5 busbars for interconnection



screen-printing-process/(accessed 29 May 2025).



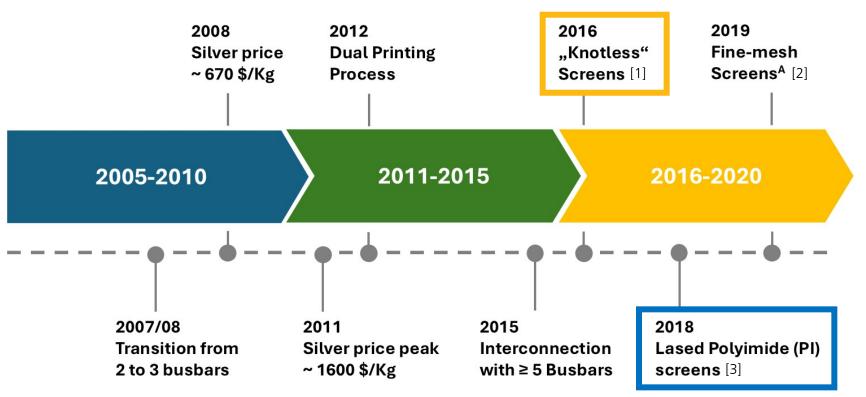


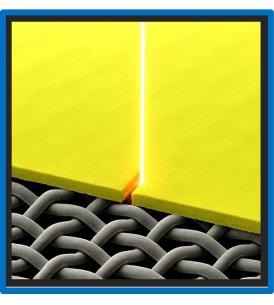
Microscopic image of knotless screen (500-05 / 0° mesh)



A Fine mesh screens ≥ 480 wires/mesh

screen-printing-process/(accessed 29 May 2025).

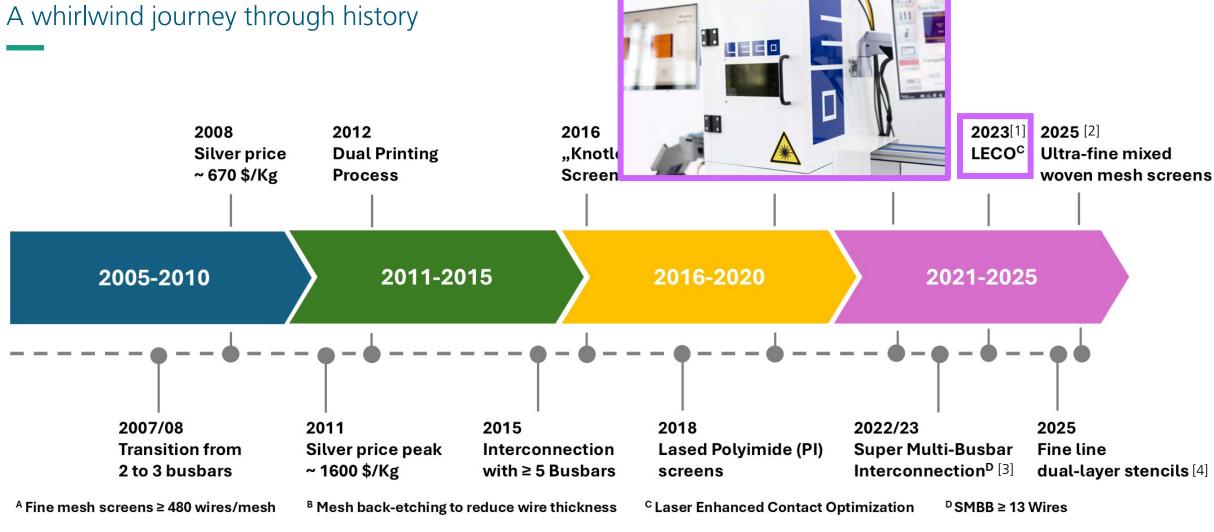




Al-created visualization of lasing process for Polyimide screens (Source: A. Lorenz, ISE)

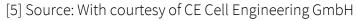


A Fine mesh screens ≥ 480 wires/mesh



[5]

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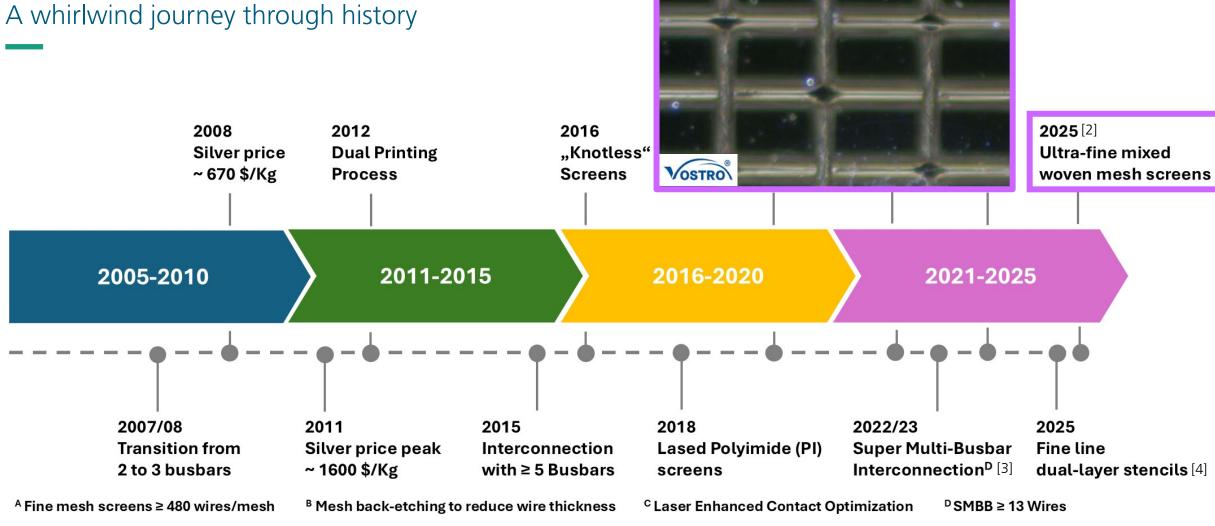
¹⁰

^[1] Höffler, H. et al., AIP Conf. Proc. 2826, 040002 (2023)

^[2] Product information, Vostro Electronic Technology Co. Ltd. (2025)

^[3] JA Solar, 20th China SoG Silicon and PV Power Conference (2024)

^[4] N. Chen et al., Sol. Energy Mater. Sol. Cells 290 (2025)



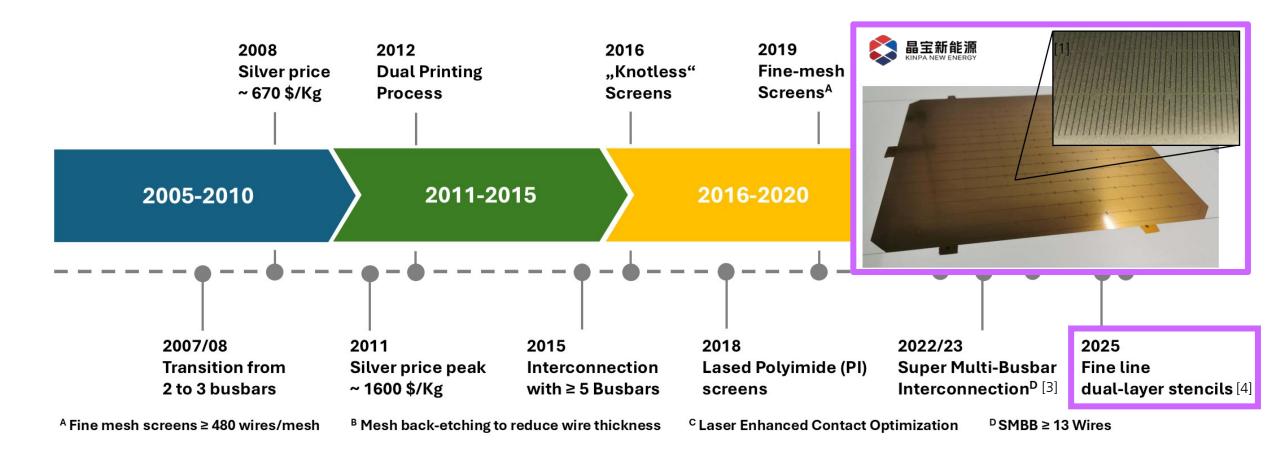


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[1] Höffler, H. et al., AIP Conf. Proc. 2826, 040002 (2023) [2] Product information, Vostro Electronic Technology Co. Ltd. (2025) [3] JA Solar, 20th China SoG Silicon and PV Power Conference (2024) [4] N. Chen et al., Sol. Energy Mater. Sol. Cells 290 (2025)



A whirlwind journey through history



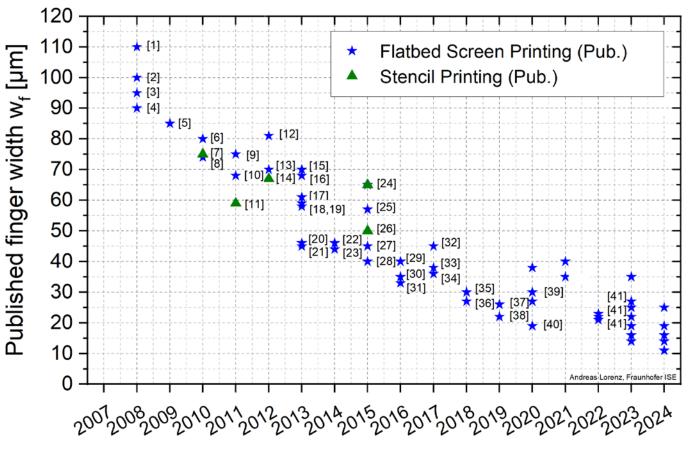


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A whirlwind journey through history



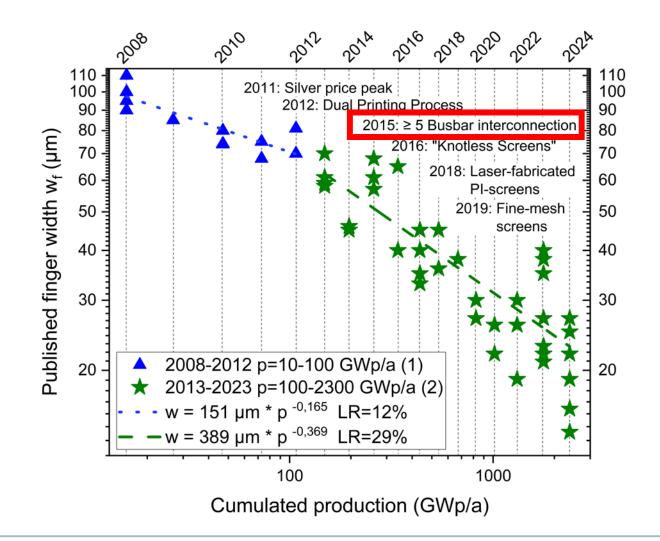
Linear learning curve of screen printed finger width evolution from 2008 to 2025. Updated version based on [1,2], References see [2],

Year of Publication

A whirlwind journey through history

New learning curve model:

- Two-phase logarithmic learning curve based on published finger widths [1]
- Linked to the annual growth of the cumulated PV production volume
- Key Findings:
 - Fine line screen printing accelerated drastically from around 2014/2015 on
 - ➤ Game changer: Transition from 3 to ≥ 5 busbars for interconnection





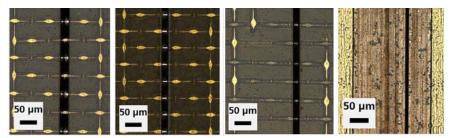
Aim and experimental setup

Aim and motivation:

- Reduction of silver by fine line printing
- Evaluation of new screen & stencil technology

Experimental setup:

- Screen/paste variation:
 - Fraunhofer ISE TOPCon precursors (M10)
 - 3 different fine mesh screen configurations
 - Varying nominal finger width / # fingers
 - High-end dual layer stencil
 - 2 high-performance Ag pastes (partly diluted)



	Screen 1 (Ref)	Screen 2	Screen 3	Stencil
Mesh/Stencil configuration	520-11 (0°)	520-09 (0°)	500-05 (0°)	Dual layer
Nom. Finger width w _n [µm]	24	20	17/15/13	9
Paste	A/B	A/B	A/B	A/B

Experimental setup – Overview of screen/stencil variations for the conducted TOPCon fine line test batch.



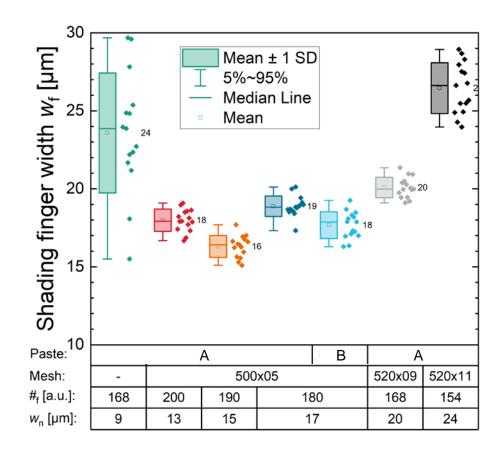




Screen / stencil printing results

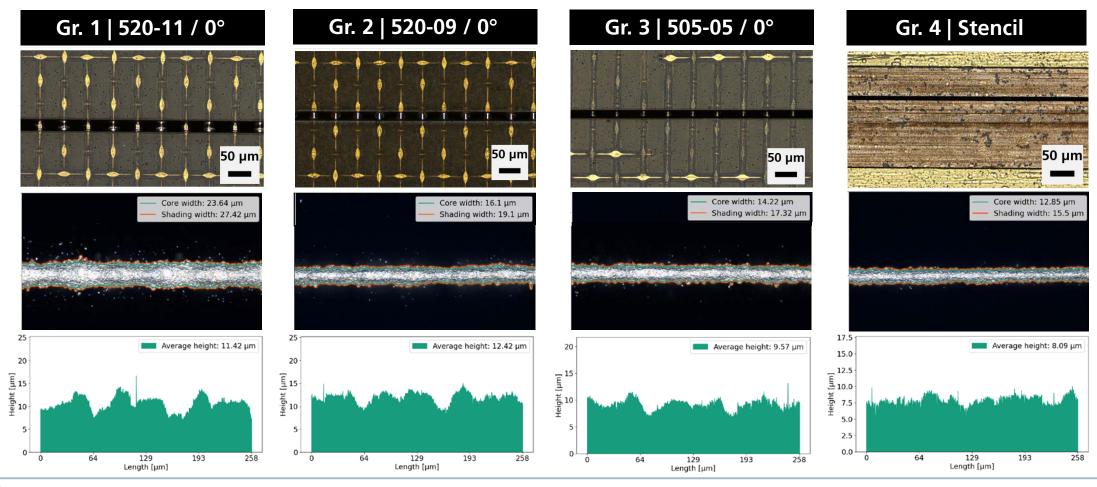
Printing results:

- Substantial finger width reduction possible with screens 500-09 and 500-05
- Best results for 500-05 (0°) mesh with $w_n = 17 \mu m$: \varnothing finger width $w_f \sim 18 \mu m$, uniform printing quality
- Stencil: improved finger uniformity, yet strong variation of finger width



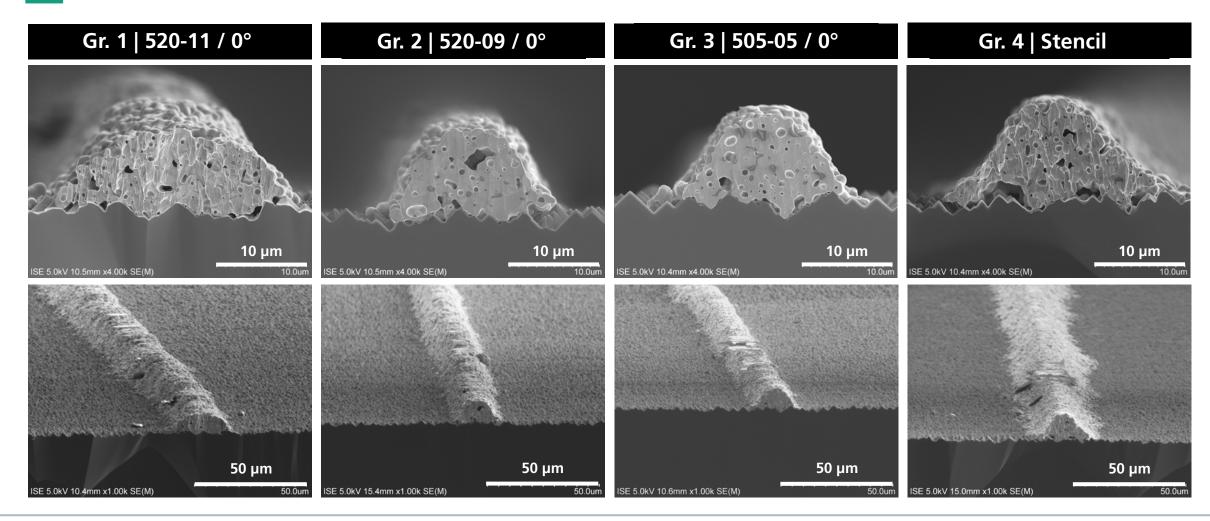


Screen / stencil printing results





Screen / stencil printing results





Screen / stencil printing results

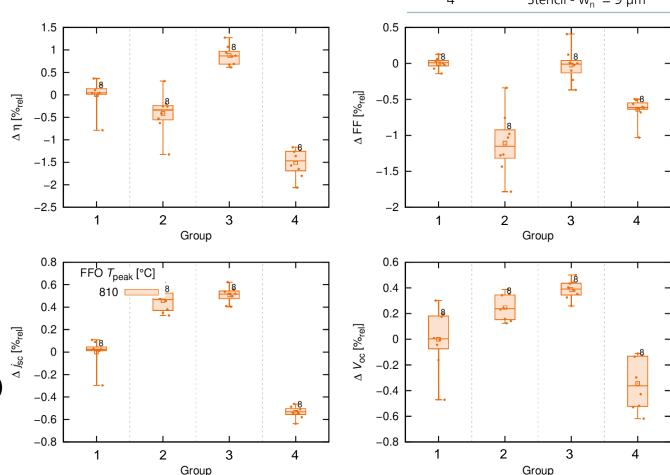
Group	Screen/Stencil	
1	520/11 0° - w _n =24 μm	
2	$520-09~0^{\circ} - w_n = 20~\mu m$	
3	$500-05~0^{\circ} - w_{n} = 17~\mu m$	
4	Stencil - $w_n = 9 \mu m$	

Results on cell level:

- J_{sc} gain up to ~ **0.55 %rel.** (group 3)
 → smaller fingers, reduced shading
- V_{oc} gain of up to ~ **0.4 %rel.** (group 3)
 → smaller fingers, reduced metal-related recombination
- FF roughly on same level as reference (gr. 3)
- Total efficiency gain: ~ **0.9 %rel.** (group 3)

Silver consumption:

• Group 3: Silver reduction $\Delta m_{Ag} = 19 \text{ mg (- 34\%)}$ compared to reference group 1

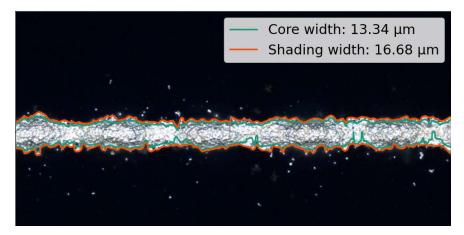


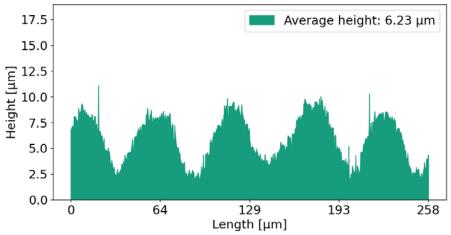


Screen / stencil printing results

Printing results:

- 500-05 Screens with finger openings (wn = 13 and 15 μ m) were printable
- Finger geometry was inconsistent (interruptions and strong height variation), result did not match "ISE quality standard"

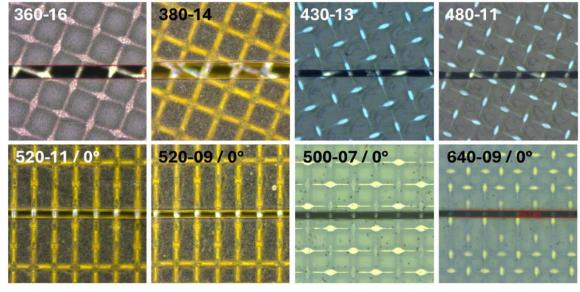




Challenges for ultra fine line printing (≤ 10 µm)

Important influencing factors:

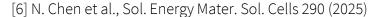
- Screen / Stencil properties [1-6]:
 - ➤ Mesh count, wire thickness, PI-layer (EOM), channel width, knotless/angled...



Variants of fine line screens with varying mesh count, wire thickness and mesh angle [Source: ISE]

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^[4] Wenzel et al., Solar Energy Materials and Solar Cells 244 (2022)



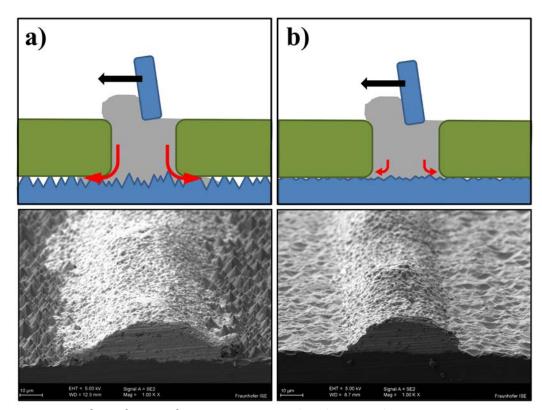


^[3] Tepner et al., IEEE J. Photovolt. 10 (2) (2020)

^[5] Tepner & Lorenz, Progr. Photovolt Res Appl 31 (6), (2023)

Challenges for ultra fine line printing (≤ 10 µm)

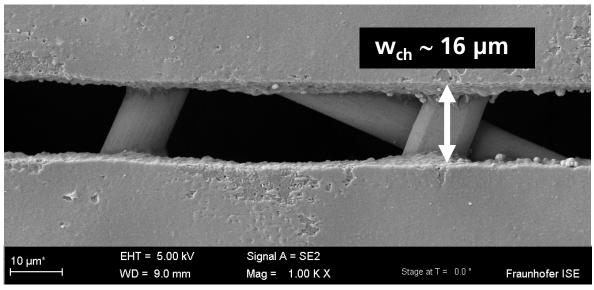
- Screen / Stencil properties:
 - Mesh count, wire thickness, PI-layer (EOM), channel width, knotless/angled...
- Surface properties and edge sealing:
 - Crticial for spreading: Edge seeling between texture and PI-barrier layer [1]
 - ➤ Influenced by texture size and PI properties [2,3]



Impact of wafer surface texture and PI barrier layer properties on uniformity and spreading of printed contacts [Source: ISE [3]

Challenges for ultra fine line printing (≤ 10 µm)

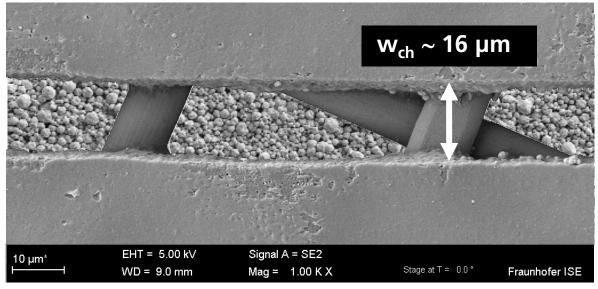
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- Paste properties & Printing conditions:
 - ➤ Rheology (i.e. dilution) [4] and particle size [5]



True-to-scale SEM image overlay of a fine-line channel in a fine mesh screen (480-11/22.5°)

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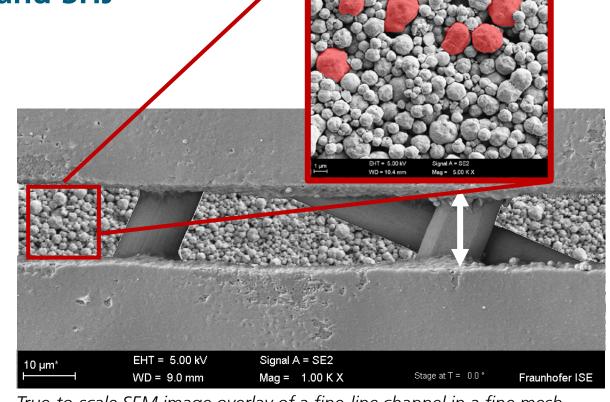


True-to-scale SEM image overlay of a fine-line channel in a fine mesh screen (480-11/22.5°) with SEM image of a PERC Paste (particle size $\sim 2-5 \, \mu m)$

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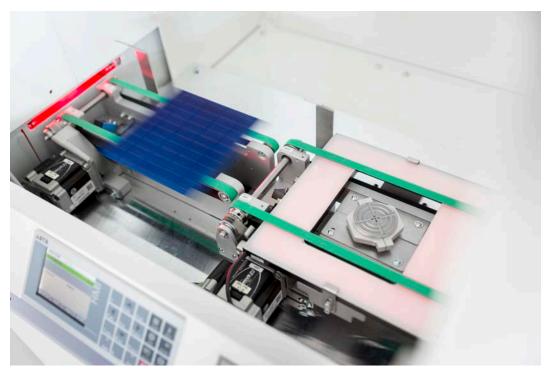


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[3] Tepner & Lorenz, Progr. Photovolt Res Appl 31 (6), (2023)

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- Surface properties and edge sealing:
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 - ➤ Influenced by texture size and PI properties [2,3]
- Paste properties & Printing conditions:
 - ➤ Rheology (i.e. dilution) [4] and particle size [5]
 - > Printing/flooding speed, cycle time of machine



Screen printing line at Fraunhofer ISE

Copper paste metallization

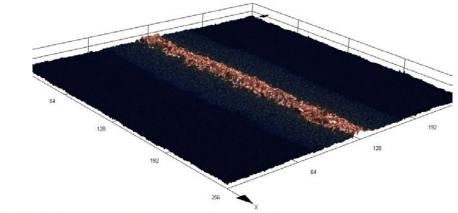
Update: Fine line screen printing of copper pastes

Aim and motivation:

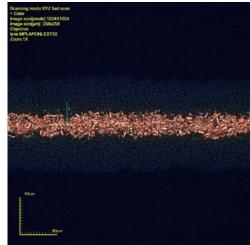
 Evaulation of pure copper pastes (LT and HT) for SHJ and TOPCon

Screen printing results:

- Strong progress regarding development of copper paste printability
- LT copper pastes can be printed down to ~20-25 μm
 width with 5-7 μm height
- Rear side metallization on SHJ [1,2] and TOPCon [3,4] successfully demonstrated width good cell results









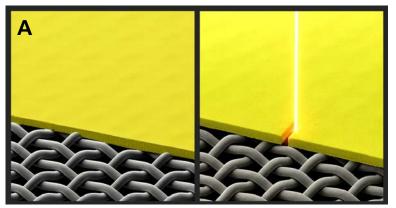
How fine can we print with screen and stencil printing?

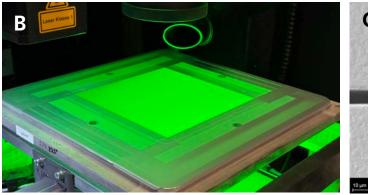
Motivation and Background:

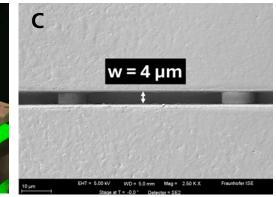
"Laser2Screen" device at Fraunhofer ISE enables laser opening of very fine lines on PI screens and stencils [1,2]

Hypothesis:

Can screen printing challenge simple photolithography applications?





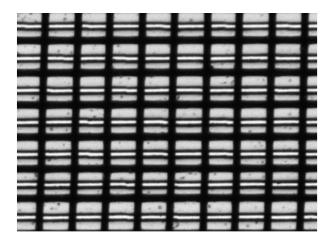


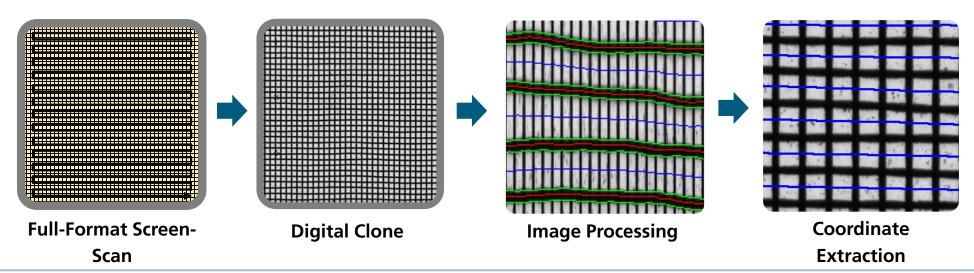
- A) Al-created visualization of laser structuring process for Pl-screens;
- B) "Laser2Screen" lasing machine at Fraunhofer ISE; C) 4 µm channel on Plscreen realized at Fraunhofer ISE (Source: ISE)

Lasing of knotless screens at Fraunhofer ISE

Lasing of 0° screens at ISE:

- ➤ Development of a processing pipeline for lasing of 0°-Screens (Knotless) at Fraunhofer ISE
- > Screen mesh analysis using OSIF full screen inspector
- ➤ Digital clone ("digital mesh") → laser coordinate extraction



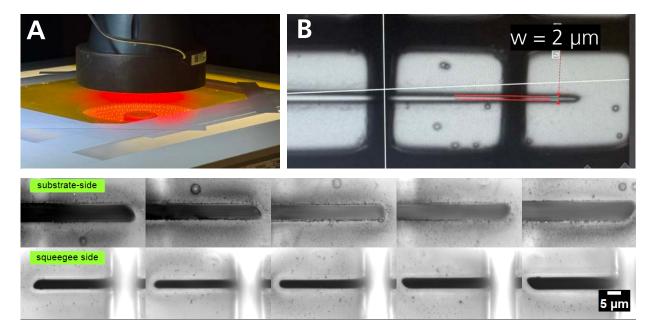




How fine can we print with screen and stencil printing?

Experimental setup:

- ➤ Laser opening of ultra fine channels using "Laser2Screen" device at Fraunhofer ISE [1,2]
 - > Screen type: 500-05 (0°) with PI layer
 - ► Laser opening: Test patches with
 1 10 µm tapered line-shaped channels
 - Screen printing with Ag-Nano Paste on ISE TOPCon precursors (rear side)



- A) Laser2Screen device for fine line structuring of screens and stencils
- B) Ultra narrow tapered channel in between two wires (500-05 mesh)
- C) Microscopic images of lased fine line channels in PI layer (Source: ISE)



How fine can we print with screen and stencil printing?

Results::

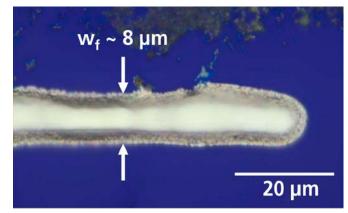
- Ultra narrow channels down to ~ 1 μm realized on PI screen
- Screen printed line width:

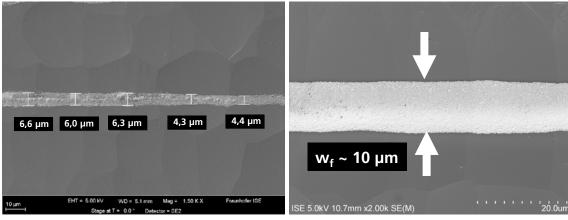
 $\mathbf{w_f} \sim 8-10 \ \mu \mathbf{m}$ (with measurable finger height)

 $w_f \sim 4-6 \mu m$ (Seed layer)

Conclusion:

- Screen printing is able to realize ultra fine lines below 10 μm
- ➤ Ultra fine line printing require intense fine tuning of paste property, wafer surface and screen configuation





Screen printed ultra fine contacts using a fine line test layout lased at Fraunhofer ISE with Ag nano paste

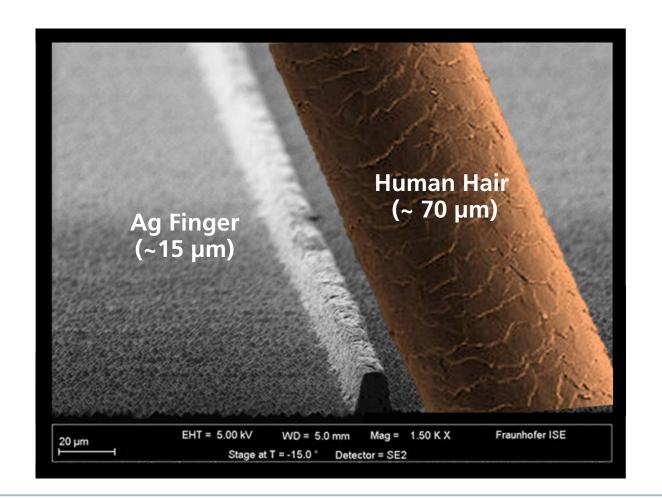


Summary and Outlook

Screen printing – Achievements and Trends

Summary:

- ➤ New learning curve model illustrates impact of disruptive innovations on evolution of fine line screen printing
- Finger width down to ~18 μm and -34% silver reduction on TOPCon obtained using high-end screens and stencils
- Printing of finer fingers possible, major challenge: printing conditions / cycle time
- > Ultra fine fingers demonstrated: $\mathbf{w_f} \sim \mathbf{8-10} \; \mu \mathbf{m}$ (width measurable height) $\mathbf{w_f} \sim \mathbf{4-6} \; \mu \mathbf{m}$ (seed layer)





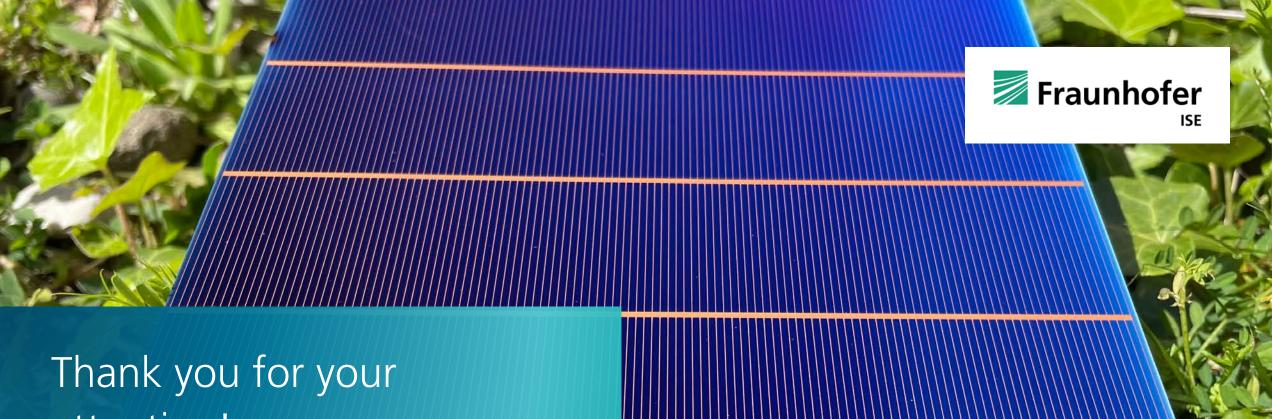
Summary and Outlook

Screen printing – Achievements and Trends

Trends for metallization:

- ➤ Screen printing has not reached the resolution limit
 → Finger width < 10 µm in mass production will come
- ➤ High-end stencils will increasingly gain importance
- Screen printable AgCu, Cu and Ni pastes will likely replace silver pastes in the mid future
- \triangleright Assumption: Sustainability target of < 2 mg/W_p in mass production is possible with screen printing





attention!

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Special Thanks to:











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